

SEP 01 2006

S/N 10/757,864

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	KITAOKA ET AL.	Examiner:	SONG
Serial No.:	10/757,864	Group Art Unit:	1722
Filed:	JANUARY 15, 2004	Docket No.:	10873.1391US01
Title:	METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark office on  
September 1, 2006.

By: 

Name: Gina Dahl

AMENDMENT AND RESPONSE

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed May 2, 2006, please amend the above-identified  
application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this  
paper.

**Remarks** begin on page 6 of this paper.